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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Mail Stop: ISSUE FEE**  
Akihisa HONGO et al. : **Confirmation No. 7681**  
Serial No. 09/842,650 ✓ : [Group Art Unit 1763  
Filed April 27, 2001 : Examiner S. Macarthur]

REVOLUTION MEMBER SUPPORTING  
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**RESPONSE TO ALLOWANCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
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ACCOUNT NO. 23-0975

Sir:

Applicant hereby requests that the Information Disclosure Statement filed with the Patent Office on January 2, 2004 be considered by the Examiner. Applicant also requests that the Examiner return an initialed copy of the form PTO-1449 which was filed as part of the Information Disclosure Statement on January 2, 2004. Enclosed herewith are copies of the Information Disclosure Statement, form PTO-1449, references, and date-stamped postcard receipt as evidence that the Information Disclosure Statement was submitted.

Respectfully submitted,

Akihisa HONGO et al.

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